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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Group Art Unit: 2818

Satoshi INOUE

Application No.: 10/814,169

Examiner: D. Nhu

Filed: April 1, 2004

Docket No.: 119330

For:

METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE, INTEGRATED CIRCUIT, ELECTRO-OPTICAL DEVICE, AND ELECTRONIC APPARATUS

AMENDMENT UNDER 37 C.F.R. §1.111

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In reply to the Office Action mailed January 7, 2005, please amend the aboveidentified application, as follows:

Amendments to the Claims as reflected in the listing of claims; and Remarks.